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## **U.S. PATENT DOCUMENTS**

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Exam. Initial	TRADEN	Document Number	Date	Name	Class	Sub Class	Filing Date
T.T.	AA	5,862,275	1/19/1999	Takeuchi et al.			
7:7.	AB	5,636,072	6/3/1997	Shibata et al.			
7.7.	AC	5,774,257	6/30/1998	Shibata et al.			
T.T.	AD	6,028,978	2/22/2000	Takeuchi et al.			
77	AE	4,113,360	9/12/1978	Baur et al.			
τ.τ.	AF	5,771,321	6/23/1998	Stern			
T.T.	AG	5,953,469	9/14/1999	Zhou			
7.7.	AH	6,091,182	7/18/2000	Takeuchi et al.			
7-1-	AI	6,108,479	8/22/2000	Takeuchi et al.			

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		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
₹त,	AJ	0 675 477 A1	10/4/1995	EP			~	
7.7.	AK	54-142089	5/11/1979	JP				~
T.T.	AL	7-287176	10/31/1995	JP				~
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1.7.	AN	11-72721	3/16/1999	JP				V
1.7.	AO	0 408 305 B1	3/13/1996	EP			<b>'</b>	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages Etc.)

7-7.	AP	Kazuo Anzai, "Preparation of Electronic Materials by Electrophoretic Deposition," General Institute of Toshiba Corporation, Denki Kagaku 53, No. 1, 1985, pp 63-68.			
T.T.	AQ	Atsushi Goto et al., PbZrO <sub>3</sub> /PbTiO <sub>3</sub> Composite Ceramics Fabricated by Electrophoretic Deposition," Tokyo Metropolitan University, Tokyo Medical and Dental University, Proceedings of First Symposium on Higher-Order Ceramic Formation Method Based on Electrophoresis, 1998, pp 5 and 6.			
T.T.	AR	Kimihiro Yamashita, "Hybridization of Ceramics by Electrophoretic Deposition," Institute for Medical and Dental Engineering, Tokyo Medical and Dental University, Proceedings of First Symposium on Higher-Order Ceramic Formation Method Based on Electrophoresis, 1998, pp 23-24.			
Examiner		TUYEN TRA Date Considered 3-17-02			

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.